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PATENT
81872.0050

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

INOMATA, et al.

Serial No: 10/648,429

Filed: August 26, 2003

For: METHOD AND APPARATUS FOR
PROCESSING SUBSTRATE AND
PLATE USED THEREIN

Art Unit: 1763

Examiner: Not Assigned

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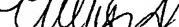
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450, on

October 29, 2004

Date of Deposit

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10/29/04

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STATUS REQUEST

Commissioner for Patents
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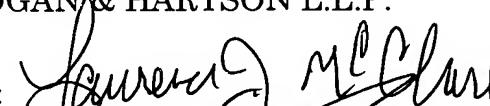
Dear Sir:

This application was filed on August 26, 2003 and receipt by the U.S. Patent and Trademark Office was acknowledged in the Filing Receipt dated November 19, 2003. A Notice of Recordation of Assignment Document was the last correspondence from the Patent Office. However, no Office Action has yet been received. Accordingly, Applicants request to be advised of the status of the application, including an indication of when the patent application is expected to be examined.

Please send the undersigned a Status Report on this application.

Respectfully submitted,
HOGAN & HARTSON L.L.P.

Date: October 29, 2004

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